

Docket No.: 55071-329

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
: Confirmation Number:
Douglas VAN DEN BROEKE, et al. :
Serial No.: Group Art Unit:
Filed: January 14, 2004 : Examiner: Unknown
:
For: METHOD AND APPARATUS FOR PROVIDING OPTICAL PROXIMITY FEATURES
TO A RETICLE PATTERN FOR DEEP SUB-WAVELENGTH OPTICAL
LITHOGRAPHY

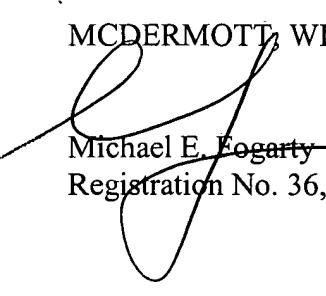
**CLAIM OF PRIORITY FROM
PROVISIONAL APPLICATION**

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

U.S. Provisional Patent Application No. 60/439,807, filed January 14, 2003

Respectfully submitted,

MCDERMOTT WILL & EMERY


Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 MEF:tlb
Facsimile: (202) 756-8087
Date: January 14, 2004